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J. Anter

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Akito Nishimura et al
Serial No. : To Be Assigned
Filed : December 20, 2000
For : OPTICAL FERRULE AND METHOD OF MOLDING
THE SAME, AND OPTICAL CONNECTOR USING THE
SAME
Group Art Unit : N/A
Examiner : N/A

December 19, 2000

Assistant Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

S I R:

In accordance with 37 CFR § 1.56 and § 1.97(b), Applicants wish to call the attention of the Examiner to the references listed below.

Japanese No. 11-72651

Japanese No. 7-56054

Japanese No. 63-16112

Japanese No. 4-77419

Copies of these references are submitted herewith along with Form PTO-1449.

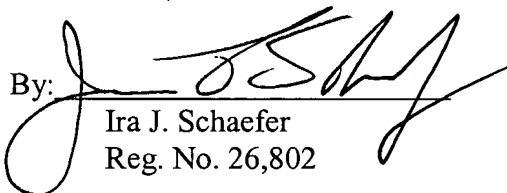
The relevance of the listed references is as follows.

Each of the references were cited in the Search Report issued by the Japanese Patent Office. A copy of this Search Report is enclosed. For the Examiner's information, the destination "X" on the Search Report is translated to mean the document is "particularly relevant if taken alone"; "Y" means "particularly relevant if combined with another document of the same category"; "A" means "technological background"; "O" means "non-written disclosure"; "P" means "intermediate document"; "T" means "theory or principle underlying the invention"; "E" means "earlier patent document, but published on, or after the filing date"; "D" means "document cited in the application"; and "L" means "document cited for other reasons".

Consideration of the foregoing in relation to this application is respectfully requested.

Respectfully submitted,

CHADBOURNE & PARKE LLP

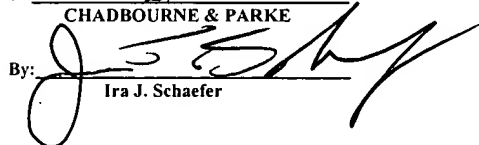
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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231

on December 20, 2000

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